



RECEIVED  
FEB 09 2004  
TC 1700

520.36911VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. ONO, et al  
Serial No.: 09/691,119  
Filed: October 19, 2000  
For: METHOD AND APPARATUS FOR TREATING SURFACE OF SEMICONDUCTOR  
Group: 1763  
Examiner: A. Olsen

AMENDMENT AFTER FINAL ACTION

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 29, 2004

Sir:

In response to the Office Action September 30, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.